

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

TASHIRO et al.

Application No. Unassigned

Filed: March 2, 2004

Art Unit: Unassigned

Examiner: Unassigned

For: SEMICONDUCTOR LASER DEVICE  
AND METHOD FOR FABRICATING THE  
SAME

**PRELIMINARY AMENDMENT**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.

In re Appln. of TASHIRO et al.  
Application No. Unassigned

*TITLE AMENDMENTS:*

Replace the title with:

METHOD OF FABRICATING SEMICONDUCTOR LASER